

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mikihiko ISHII et al.

Application No.: New U.S. Continuing Application

Filed: March 18, 2004

Docket No.: 119132

For: METHOD AND APPARATUS FOR POINT DIFFRACTION INTERFEROMETRY

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Remarks.